



PATENT

8565D-7213 (81839.0077)

Express Mail Label No. EL 713 623 895 US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Teruaki FUKAMI

Serial No: 09/218,997

Filed: December 22, 1998

For: SILICON WAFER STORAGE
WATER AND SILICON WAFER
STORAGE METHOD

Art Unit: 1744

Examiner: I. Soubra

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PETITION FOR EXTENSION OF TIME

Box CPA
Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a 2-month extension of time extending to November 18, 2001, the period for response to the Final Office Action dated June 18, 2001. A check for \$400 is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

11/27/2001 GTEFFERA 00000058 09218997

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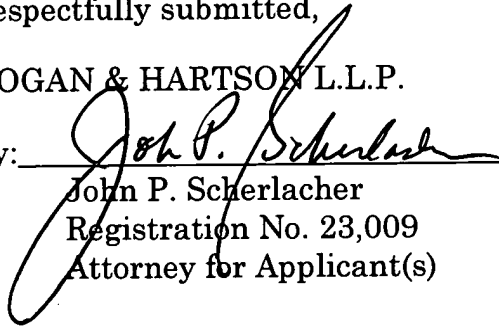
400.00 OP

Date: November 15, 2001

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By:


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